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semiconductor and ((thin adj film) or TFT) and clean\$ and in-situ

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US Patents Full-Text Database
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Database: IBM Technical Disclosure Bulletins**Refine Search:**semiconductor and ((thin adj film) or
TFT) and clean\$ and in-situ**Clear****Search History****Today's Date:** 1/11/2002

<u>DB Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
DWPI	semiconductor and ((thin adj film) or TFT) and clean\$ and in-situ	2	<u>L1</u>
USPT	semiconductor and ((thin adj film) or TFT) and clean\$ and in-situ	607	<u>L2</u>
PGPB	semiconductor and ((thin adj film) or TFT) and clean\$ and in-situ	55	<u>L3</u>
JPAB	semiconductor and ((thin adj film) or TFT) and clean\$ and in-situ	0	<u>L4</u>
EPAB	semiconductor and ((thin adj film) or TFT) and clean\$ and in-situ	0	<u>L5</u>
TDBD	semiconductor and ((thin adj film) or TFT) and clean\$ and in-situ	0	<u>L6</u>